

<b>Notice of References Cited</b>	Application/Control No. 10/001,483	Applicant(s)/Patent Under Reexamination ROTONDARO, ANTONIO L. P.	
	Examiner Michelle Estrada	Art Unit 2823	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ghandhi, Sorab K., "VLSI Fabrication Principles", 1983 by John Wiley & Sons, Inc., pages 517-520.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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